

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshiro SHIOKAWA, Megumi NAKAMURA,  
Tohru SASAKI and Toshihiro FUJII

Application No.: New US Patent Application

Filed: June 1, 2001

Docket No.: 109675

For: METHOD AND APPARATUS FOR ION ATTACHMENT MASS SPECTROMETRY

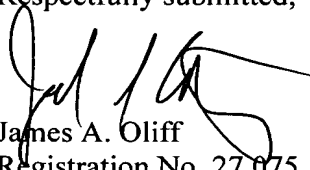
INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the references is discussed in the present specification.
- ☒ 3. An English-language Abstract of the non-English language reference is attached hereto.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075Joel S. Armstrong  
Registration No. 36,430JAO:JSA/zmc  
Date: June 1, 2001OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

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